

**Notice of References Cited**

Application/Control No.

10/676,819

Applicant(s)/Patent Under  
Reexamination  
WEDEL ET AL.

Examiner

Qing Chen

Art Unit

2191

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,386,834 B2	06-2008	Van De Vanter et al.	717/110
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	J	US-			
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	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

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